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AO/0926/03

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/675,419
Art Unit: 1756
Applicant: John M. Kulp
Title: **SACRIFICIAL SURFACTANATED PRE-WET FOR DEFECT
REDUCTION IN A SEMICONDUCTOR PHOTOLITHOGRAPHY
DEVELOPING PROCESS**
Attorney Docket: CT-001
Confirmation No.: 6182

Cincinnati, OH

February 9, 2007

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

This paper is responsive to the final Office Action mailed October 11, 2006. The Examiner has indicated that claims 1-35 are pending in the application and are rejected. The present response includes the following:

Amendments to the Specification:	None
Amendments to the Claims:	Pages 2-9
Amendments to the Abstract:	None
Amendments to the Drawings:	None
Remarks:	Pages 10-12
Attachments:	None